



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: SAMUKAWA et al.
Serial No.: 10/501,351
Filed: July 14, 2004
For: On-Wafer Monitoring System
Group: 1763 Confirmation No. 7535
EXAMINER: Dhingra, Rakesh Kumar DOCKET: SHIG CPTA0502FE

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C WITH
REQUEST FOR CONTINUED EXAMINATION (RCE)

Dear Sir:

This Amendment is being filed in response to the Final Action mailed August 31, 2007.

A Request for Continued Examination (RCE) accompanies this Amendment.

Please amend the Application as follows:

Amendments to the Claims begin on page 2 of this Amendment.

Remarks/Arguments begin on page 5 of this Amendment.

HAYES SOLOWAY P.C.
3450 E. SUNRISE DRIVE,
SUITE 140
TUCSON, AZ 85718
TEL. 520.882.7623
FAX. 520.882.7643

175 CANAL STREET
MANCHESTER, NH 03101
TEL. 603.668.1400
FAX. 603.668.8567